# Simulation Statistics 

By Sagar and Siddhant
Under the guidance of Dr. Ankhi Roy, Dr. Chris Pinkenburg, and Dr. Kolja Kauder

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IIT Indore

## Contents

Histograms for energy resolution of detectors with manual clustering, 360 MeV energy cut on aggregate towers of EMCs (FEMC and CEMC), and slice-wise calibration, for the following detector-particle pairs:

- Pion: FHCAL + FEMC
- Pion: CEMC + HCALIN + HCALOUT


## Simulation Parameters

- Particles: $\mathrm{pi}^{-}$
- Events: 150,000 pi ${ }^{-}(100,000 \rightarrow 0-30 \mathrm{GeV} / \mathrm{c}, 50,000 \rightarrow 0-2 \mathrm{GeV} / \mathrm{c})$
- momentum (p): 0 to $30 \mathrm{GeV} / \mathrm{c}$
- Pseudorapidity ( n ): -4 to 4
- Azimuth (Ф): $-\boldsymbol{\pi}$ to $\boldsymbol{\pi}$


## Cuts:

- Detector-wise $\eta$ cuts, intersection for combinations
- Detector-wise Elliptical cuts in dphi vs dtheta plots
- Energy cut on individual Towers of EMCs (360 MeV)


## FEMC + FHCAL (pi-)

## FEMC (pi-)

te vs counts
Explicit $\eta$ cut: 1.3 to 3.3
No energy cut


Energy deposition in FEMC to deduce MIPS threshold

## FEMC + FHCAL (pi$)$

Elliptical cut on dphi vs dtheta
Explicit $\eta$ cut: 1.3 to 3.3
360 MeV Aggregate Energy Cuts on EMC Towers

After calibration

$\left(\right.$ te $_{\text {agg }} \rightarrow \sum\left(\right.$ weight** $^{*}$ /calibrationFactor)/mean( $\sum\left(\right.$ weight* $^{*}$ te/calibrationFactor))

Each slice of (teagg-ge)/ge vs ge plot will be calibrated on the basis of dividing by a calibration factor which equals to the Mean of teagg/ge corresponding to that particular slice in this plot.

## FEMC + FHCAL (pi-)

(te ${ }_{\text {agg }}-\mathrm{ge}$ )/ge vs ge
Explicit $\eta$ cut: 1.3 to 3.3
360 MeV Aggregate Energy Cuts on EMC Towers


After calibration

 calibrationFactor(ge) = mean(te/ge) ; detector-wise; function of ge

# FEMC + FHCAL (pi-) 

## $\sigma_{-} \mathrm{e}_{\text {agg }}$ vs ge

Explicit $\eta$ cut: 1.3 to 3.3
Elliptical Cut for Manual Clustering
360 MeV Aggregate Energy Cuts on EMC Towers

$\sigma e$ refers to the standard deviation of the Gaussian
fitted to a slice of the calibrated (teagg-ge)/ge vs ge plot.

Number of bins $=10$
Bin Width $=3 \mathrm{GeV}$
Fit Parameters:
$p_{o}=(0.123222+-0.00462695)$
$\mathrm{p}_{1}=(0.222539+-0.0155956) \mathrm{GeV}^{0.5}$

## FEMC + FHCAL (pi-)

Explicit $\eta$ cut: 1.3 to 3.3
Elliptical Cut for Manual Clustering 360 MeV Aggregate Energy Cuts on EMC Towers


Cuts on aggregate EMC Towers


## FEMC + FHCAL (pi-)

Explicit $\eta$ cut: 1.3 to 3.3
Elliptical Cut for Manual Clustering 360 MeV Aggregate Energy Cuts on EMC Towers


Mean of the Gaussians fitted to the slices of the calibrated (te ${ }_{\text {agg }}-$ ge)/ge vs ge plot.


Reduced_x2 of the Gaussians fitted to the slices of the calibrated (te ${ }_{\text {agg }}-$ ge)/ge vs ge plot.

## FEMC + FHCAL (pi)

## Fitted Gaussians






The x-axes denote $\Delta \mathrm{e}_{\mathrm{agg}} / \mathrm{ge}$

## CEMC + HCALIN + HCALOUT (pi')

## CEMC (pi-) <br> te vs counts

Explicit $\eta$ cut: -1.1 to 1.1
No energy cut


Energy deposition in CEMC to deduce MIPS threshold

# CEMC + HCALIN + HCALOUT (pi) <br> Elliptical cut on dphi vs dtheta 

Explicit $\eta$ cut: -1.1 to 1.1
360 MeV Aggregate Energy Cut on EMC Towers

After calibration

$\left(\right.$ te $_{\text {agg }} \rightarrow \sum\left(\right.$ weight** $^{*}$ /calibrationFactor)/mean( $\sum\left(\right.$ weight* $^{*}$ te/calibrationFactor))

Each slice of (teagg-ge)/ge vs ge plot will be calibrated on the basis of dividing by a calibration factor which equals to the Mean of teagg/ge corresponding to that particular slice in this plot.

## CEMC + HCALIN + HCALOUT (pi')

(te ${ }_{\text {agg }}$-ge)/ge vs ge
Explicit $\eta$ cut: -1.1 to 1.1
360 MeV Aggregate Energy Cut on EMC Towers


After calibration


calibrationFactor(ge) = mean(te/ge) ; detector-wise; function of ge
weight $=$ mean(te/ge) ; detector-wise; independent of ge

# CEMC + HCALIN + HCALOUT (pi') <br> $\sigma_{-} e_{\text {agg }}$ vs ge 

Explicit $\eta$ cut: - 1.1 to 1.1
Elliptical Cut for Manual Clustering
360 MeV Aggregate Energy Cuts on EMC Towers

$\sigma e$ refers to the standard deviation of the Gaussian fitted to a slice of the calibrated (teagg-ge)/ge vs ge plot.

Number of bins $=10$
Bin Width $=3 \mathrm{GeV}$
Fit Parameters:
$p_{o}=(0.218467+-0.00527894)$
$p_{1}=(0.150429+-0.0165214) \mathrm{GeV}^{0.5}$

## CEMC + HCALIN + HCALOUT (pi)

Explicit $\eta$ cut: -1.1 to 1.1
Elliptical Cut for Manual Clustering
360 MeV Aggregate Energy Cuts on EMC Towers

## Cuts on individual EMC Towers



## Cuts on aggregate EMC Towers



## CEMC + HCALIN + HCALOUT (pi)

Explicit $\eta$ cut: - 1.1 to 1.1
Elliptical Cut for Manual Clustering
360 MeV Aggregate Energy Cuts on EMC Towers


Mean of the Gaussians fitted to the slices of the calibrated
(te ${ }_{\text {agg }}-$ ge)/ge vs ge plot.


Reduced_X2 of the Gaussians
fitted to the slices of the calibrated
(te agg -ge)/ge vs ge plot.

## CEMC + HCALIN + HCALOUT (pi-)

Fitted Gaussians


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